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Attorney Docket No.: 291958170US2  
Semitool Ref. No.: P99-0006US3  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Ritzdorf et al.

Application No.: 09/885,451

Confirmation No.: 3390

Filed: June 20, 2001

Art Unit: 1742

For: METHOD AND APPARATUS FOR LOW  
TEMPERATURE ANNEALING OF  
METALLIZATION MICRO-STRUCTURES IN  
THE PRODUCTION OF A  
MICROELECTRONIC DEVICE

Examiner: W. T. Leader

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated September 22, 2004, please amend the above-identified U.S. patent application as reflected in the following listing of claims starting on page 2. Additionally, please find enclosed a Declaration of Thomas L. Ritzdorf under 35 C.F.R. § 1.131 and a petition for a three-month extension of time under 37 C.F.R. 1.136.